

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



#1019
7/1/03

Applicant(s): Antonius Henricus Maria Raaijmakers et al.
Serial No.: 09/745,914
For: ELECTRO-OPTICAL DEVICE HAVING AN ITO LAYER,
A SiN LAYER AND AN INTERMEDIATE SILICON
OXIDE LAYER

Filed: December 22, 2000

Examiner: Chung, David Y.

Group Art Unit: 2871

Attorney Docket No.: PHN 17,819

Mail Stop: Non-Fee Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT RESPONSE

Dear Sir:

In response to the Office Action dated April 11, 2000,
please amend the above-noted application as follows:

IN THE SPECIFICATION

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Please amend the specification as follows:

Page 1, line 1, insert:

a, --BACKGROUND OF THE INVENTION

1. Field of the Invention--

Page 1, line 6, insert:

a2 --2. Description of the Related Art--

Page 2, line 3, insert: